

HAVERSTOCK & OWENS LLP  
162 North Wolfe Road  
Sunnyvale, California 94086  
(408) 530-9700

Customer Number 28960

MAIL STOP NEW PATENT APPLICATION  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Attorney Docket No.: SSI-04001

NEW APPLICATION TRANSMITTAL

Sir:

Transmitted herewith for filing is the patent application of Inventor: William Dale Jones

Title: HIGH-PRESSURE PROCESSING CHAMBER FOR A SEMICONDUCTOR WAFER

CERTIFICATION UNDER 37 CFR § 1.10

I hereby certify that this New Application and the documents referred to as enclosed herein are being deposited with the United States Postal Service on this date, October 6, 2003, in an envelope bearing "Express Mail Post Office To Addressee" Mailing Label Number EL967843657US addressed to: PATENT APPLICATION, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Francis Guerra  
(Name of Person Mailing Paper)

[Signature]  
Signature

Enclosed are:

1. The papers required for filing date under CFR § 1.53(b):  
36 Pages of Specification (including claims); 14 Sheet(s) of Drawings.  
X Formal  
- Informal
2. X Declaration or Oath (combined with Power of Attorney)
3. X Power of Attorney (combined with Declaration)
4. X Assignment of the Invention to Supercritical Systems, Inc. (including Form PTO-1595).
5. Fee Calculation

CLAIMS AS FILED

	Number Filed	Number Extra	Rate	Basic Fee
				\$770.00
Total Claims	16-20	0	\$18.00	0.00
Independent Claims	3-3	0	\$86.00	0.00
Multiple Dependent claim(s), if any			\$280.00	
			Filing Fee Calculation	\$770.00

6. Other Fees  
X Assignment Recordation Fee \$40.00  
- Other 0.00  
**TOTAL FEES ENCLOSED \$810.00**

7. Payment of Fees  
X Check in the amount of \$810.00 ( The basic filing fee of \$770.00 plus \$40.00 for the assignment recordation fee) enclosed.

8. X Authorization to Charge Additional Fees  
The Commissioner is hereby authorized to charge any additional fees (or credit any overpayment) associated with this communication and which may be required under 37 CFR § 1.16 or § 1.17 to Account No. 08-1275. An originally executed duplicate of this transmittal is enclosed for this purpose.

9. X Return Receipt Postcard
10. X Request for Non-Publication

Dated: October 6, 2003

By: Thomas B. Haverstock  
Name: Thomas B. Haverstock  
Registration No.: 32,571



PATENT

Attorney Docket No.: SSI-04001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

**William Dale Jones**

Serial No.:

Filed: herewith

For: **HIGH-PRESSURE PROCESSING  
CHAMBER FOR A  
SEMICONDUCTOR WAFER**

Group Art Unit:

Examiner:

**REQUEST FOR NON PUBLICATION OF  
APPLICATION UNDER 35 U.S.C. §122(b)**

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Customer No.:

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Alexandria, VA 22313-1450

Sir:

I hereby certify that the invention disclosed in the attached application has not and will not be the subject of an application filed in another country, or under a multilateral agreement, that requires publication at eighteen months after filing.

I hereby request that the attached application not be published under 35 U.S.C. 122(b).

Respectfully submitted,  
HAVERSTOCK & OWENS LLP

Dated: 10-6-03

By:

Thomas B. Haverstock

Thomas B. Haverstock

Reg. No.: 32,571

Attorneys for Applicant